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U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class/ Subclass
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FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class/ Subclass

OTHER DOCUMENTS

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lz "Horizontal Wafer Transfer Machines", Handling tools and equipment for the semiconductor industry since 1975!, H-Square Corporation, Sunnyvale, California, pp. 8-1 - 8-5.

lz "E.T. 1000 Wafer Transfer System", "E.T. 2000 Wafer Transfer System", and "Ergonomic Wafer Transfer System", MGI Electronics, Tempe, Arizona.

Examiner

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9-26-03